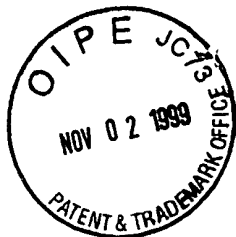


35.G2387



PATENT APPLICATION

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
HIDEHIKO FUJIMURA, ET AL.) Examiner: Unassigned
Application No.: 09/309,766) Group Art Unit: Unassigned
Filed: May 11, 1999)
For: METHOD FOR MANUFACTURING) November 2, 1999
AIRTIGHT VESSEL AND)
IMAGE-FORMING APPARATUS)
USING AIRTIGHT VESSEL)

The Assistant Commissioner for Patents
Washington, D.C. 20231

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Group 3700

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under
37 C.F.R. § 1.56 and in accordance with the practice under
37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is
directed to the documents listed on the enclosed Form
PTO-1449. Copies of the listed documents are also enclosed.

The concise explanations of relevance for the non-
English documents are provided in the Description of Related
Art section of the specification.

CONCLUSION

It is respectfully requested that the above
information be considered by the Examiner and that an

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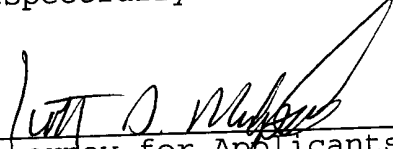
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FEB 23 2000 APR 11 2000
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initialed copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,


Attorney for Applicants

Registration No. 32,533

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

SDM\rnm

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY DOCKET NO.
35.G2387APPLICATION NO.
09/309,766LIST OF REFERENCES CITED BY APPLICANT(S)
(Use several sheets if necessary)APPLICANTS
HIDEHIKO FUJIMURA, ET AL.

Submitted to the PTO: November 2, 1999

NOV 02 1999

FILING DATE
May 11, 1999GROUP
Unassigned

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	CLASS	FILING DATE IF APPROPRIATE
	5,925,979	07/1999	Azuma, et al.	313	495	

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
7-302545	11/1995	Japan			Abstract
7-296748	11/1995	Japan			Abstract
7-296731	11/1995	Japan			Abstract

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

	W.P. Dyke, et al., "Field Emission", Advances in Electronics and Electron Physics, pp. 90-185 (1956).
	C.A. Spindt, et al., "Physical Properties of Thin-Film Field Emission Cathodes with Molybdenum Cones", Journal of Applied Physics, Vol. 47, No. 12, pp. 5248-5263 (December 1976).
	C.A. Mead, "Operation of Tunnel-Emission Devices", Journal of Applied Physics, Vol. 32, No. 4, pp. 646-652 (April 1961).
	M.I. Elinson, et al., "The Emission of Hot Electrons and the Field Emission of Electrons From Tin Oxide", Radio Engineering and Electronic Physics, No. 7, pp. 1290-1296 (July 1965).
	G. Dittmer, "Electrical Conduction and Electron Emission of Discontinuous Thin Films", Thin Solid Films, Vol. 9, pp. 317-328 (1972).
	H. Araki, et al., "Electroforming and Electron Emission of Carbon Thin Films", Journal of Vacuum Society of Japan, Vol. 26, No. 1, pp. 22-29 (January 1983).
	M. Hartwell, et al., "Strong Electron Emission From Patterned Tin-Indium Oxide Thin Films", International Electron Devices Meeting, pp. 519-521 (1975).

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.